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# Elucidating and decoupling diverse fatigue mechanisms toward static self-recovery in ZrO<sub>2</sub>-based antiferroelectrics

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ZrO<sub>2</sub>-based antiferroelectric (AFE) materials exhibit superior endurance compared to HfO<sub>2</sub>-based ferroelectrics, making them promise for nanoelectronics. Nonetheless, their endurance properties remain insufficient for dynamic random-access memory applications. In this respect, the fundamental physical mechanisms underlying polarization fatigue and the intrinsic constraints on self-recovery remain poorly understood, yet they are pivotal for achieving fatigue-free operation. Here, we systematically decouple the multiple fatigue mechanisms in ZrO<sub>2</sub>-based AFE capacitors and introduce a static self-recovery (SSR) method that significantly improves endurance. We present a three level traps model, developed by electrical measurements and first-principles calculations, that successfully describes the shallow/deep fatigue of ZrO<sub>2</sub>-based AFE materials and their SSR processes. Moreover, the SSR effect can be significantly enhanced by optimizing the combination of break time and cycling unit. The proposed SSR methodology offers a viable solution to the endurance challenges of AFE random-access memory in practical applications, paving the way for high-endurance, energy-efficient memory technologies with enhanced functional versatility.

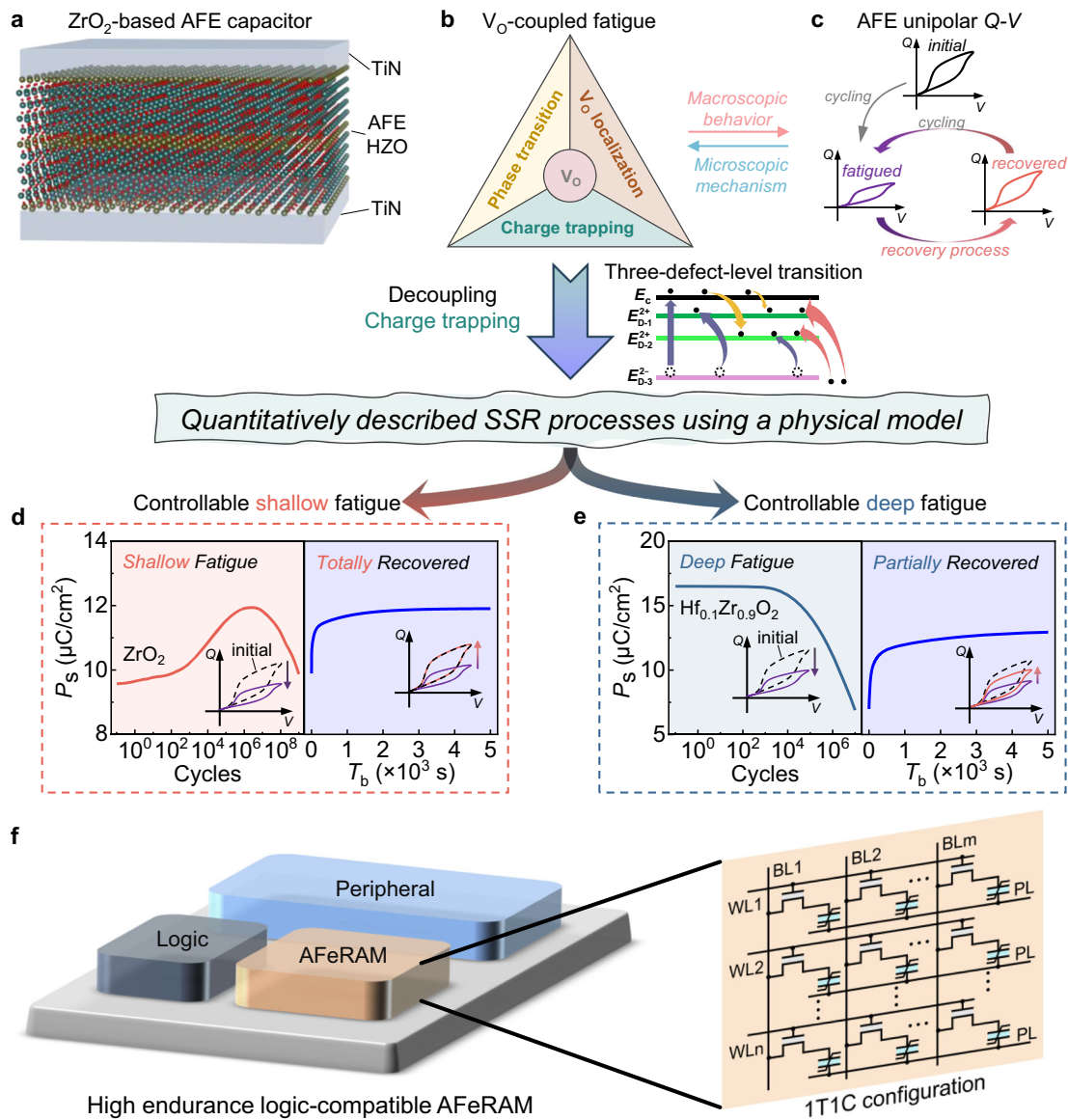
With the rapid advancement of artificial intelligence (AI) technologies, particularly deep learning models, traditional Si-based storage devices are facing growing challenges in terms of storage capacity, data transfer speeds, and energy efficiency<sup>1–4</sup>. In this context, non-volatile memory (NVM) devices emerge as a promising storage technology to overcome these issues. HfO<sub>2</sub>-based ferroelectric (FE) materials have gained widespread attention for next-generation NVM applications, thanks to their exceptional compatibility with complementary metal-oxide-semiconductor (CMOS) technology<sup>5–10</sup>. Nonetheless, achieving dependable and stable electrical performance in HfO<sub>2</sub>-based FE random-access memory (FeRAM) continues to be a significant challenge<sup>11–14</sup>. One of the key issues is the remnant polarization ( $P_r$ ) degradation during electrical cycling, which is a concern regarding their reliability<sup>15–21</sup>.

In comparison, ZrO<sub>2</sub>-based antiferroelectric (AFE) devices exhibit more excellent endurance performance as reported<sup>22–26</sup>. Despite this, their endurance properties remain insufficient for dynamic random-access memory (DRAM)-level applications. The fundamental challenge lies in the limited understanding of the correlation between microscopic fatigue

mechanisms and macroscopic electrical behavior in ZrO<sub>2</sub>-based AFE devices, which hinders further advancements in their reliability and performance optimization. It has been revealed that the evolution of oxygen vacancies ( $V_O$ ) plays a crucial role in the fatigue process of the metal-AFE-metal capacitor (Fig. 1a), which could be concluded as the coupling of  $V_O$  charge trapping, AFE to FE phase transition (PT) and  $V_O$  localization (Fig. 1b)<sup>27</sup>. A comprehensive understanding and decoupling of these three mechanisms will enable the development of a robust physical model, offering predictive and regulatory insights into the fatigue and recovery behaviors of ZrO<sub>2</sub>-based AFE capacitors while potentially unveiling intriguing underlying physical phenomena (Fig. 1c).

In this article, by decoupling  $V_O$  charge trapping, a static self-recovery (SSR) method that does not require external circuitry is proposed, as well as the three level traps model, which could precisely describe the SSR process in ZrO<sub>2</sub>-based capacitors. It is demonstrated that polarization fatigue can be effectively recovered by a certain break time ( $T_b$ ), and shallow fatigue can be totally recovered (Fig. 1d), while deep fatigue cannot (Fig. 1e). Both the SSR behaviors under shallow and deep fatigue are successfully reproduced by the

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**Fig. 1 | Proposal of the SSR method through elucidation of device fatigue mechanisms.** **a** Schematic illustration of the AFE TiN/HZO/TiN capacitors. **b**  $V_O$ -coupled fatigue mechanisms in  $ZrO_2$ -based AFE capacitors. **c** Schematic diagram of the endurance enhancement in half-loop operated AFE devices via the recovery method. Development of predictable SSR method under (d) shallow and (e) deep

fatigue situations in  $ZrO_2$ -based AFE capacitors by decoupling  $V_O$  charge trapping. Left panels are fatigue processes, and the right panels are recovery processes. The  $Q-V$  curves of initial states are illustrated by black dashed lines. **f** Application of SSR method in high endurance logic-compatible AFeRAM utilizing half-loop operation with low operating voltage.

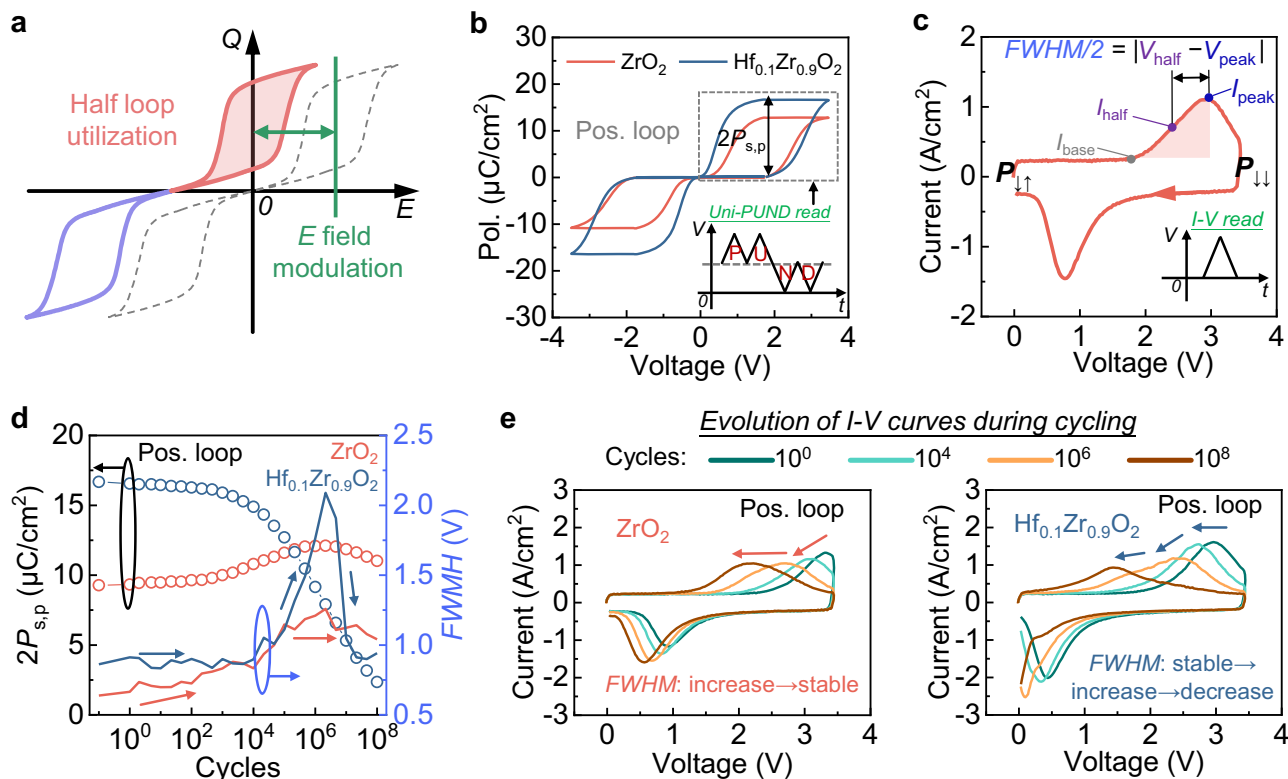
proposed three level traps model. Furthermore, by tuning the combination of  $T_b$  and the number of cycles for cycling unit, SSR ability for deep fatigue could be further optimized. This is due to the fast release of the shallow trapped charged  $V_O$ , which can effectively avoid deep fatigue. These controllable SSR processes hold promises for enhancing the endurance of logic-compatible AFE random-access memory (AFeRAM) (Fig. 1f).

**Results and discussion**

**Electrical characteristics of  $ZrO_2$ -based AFE capacitors**

AFE capacitors with the same top electrode (TE) and bottom electrode (BE) materials (Supplementary Fig. 1a) would show double hysteresis loop and zero spontaneous polarization. A lower operating voltage can be achieved by utilizing half-loop operation through build-in electric field modulation, as shown by schematic charge-voltage ( $Q-V$ ) curves in Fig. 2a, primarily realized by engineering work function differences between TE and BE<sup>24-26</sup>. Therefore, investigating the electrical properties of half-loop is vital to the application of AFE capacitors. Figure 2b shows the measured polarization-

voltage ( $P-V$ ) curves of fabricated AFE  $Hf_xZr_{1-x}O_2$  (HZO) capacitors by uni-directional positive-up-negative-down (uni-PUND) method, in which the positive (Pos.) and negative (Neg.) loops were recorded by applying +3.5 V and -3.5 V at 10 kHz, with the relax voltage ( $V_{relax}$ ) maintained at +1.75 V and -1.75 V, respectively<sup>28</sup>. Here,  $2P_{s,p}$  is used to quantitatively evaluate the AFE properties in actual applications with half-loop operation, as defined by the black arrow in the Pos. loop shown in Fig. 2b. The initial  $2P_{s,p}$  value of  $ZrO_2$  capacitor is  $12.79 \mu C/cm^2$ , which is quite smaller than the one of  $Hf_{0.1}Zr_{0.9}O_2$  capacitor ( $16.64 \mu C/cm^2$ ). Figure 2c shows the definition of full width at half maximum ( $FWHM$ ) extracted from the current-voltage ( $I-V$ ) curve, which is used to assess the spreading of coercive field ( $E_c$ ) distribution. The  $FWHM$  of  $I-V$  curve manifests the spatial dispersion of local  $E_c$  across the film. A small  $FWHM$  represents collective switching of all domains within a narrow electric field range, indicating a tightly distributed local  $E_c$ . Conversely, a large  $FWHM$  signifies asynchronous domain switching at varied electric fields, reflecting a dispersed local  $E_c$  distribution. The distribution of  $V_O$  would significantly modify the local  $E_c$ , substantially



**Fig. 2 | Electrical characteristics of  $ZrO_2$  and  $Hf_{0.1}Zr_{0.9}O_2$  capacitors. a** Evolution of the  $Q-V$  curve utilizing the half loop method for AFeRAM via electric field modulation. **b** Measured  $P-V$  curve and  $2P_{s,p}$  extracted from the Pos. loop, with the uni-PUND scheme shown in the inset. **c**  $I-V$  curve of Pos. loop and the definition of  $FWHM$  for  $P_{1\uparrow}$  to  $P_{1\downarrow}$  switching current. **d** Evolution of  $2P_{s,p}$  extracted from uni-

PUND measurements, and  $FWHM$  derived from  $I-V$  measurements for  $ZrO_2$  and  $Hf_{0.1}Zr_{0.9}O_2$  capacitors under +3.5 V, 200 kHz uni-directional cycling. **e** Evolution of  $I-V$  curves for  $ZrO_2$  and  $Hf_{0.1}Zr_{0.9}O_2$  capacitors during uni-directional  $10^8$  cycles, with the trends of  $E_c$  and  $FWHM$  indicated by arrows and annotations. Changes in  $FWHM$  suggest the redistribution of  $V_O$ .

impacting polarization switching energy barriers. When  $V_O$  are uniformly distributed, the distribution of local  $E_c$  is tight and the  $FWHM$  is small. Oppositely, the inhomogeneous distributed  $V_O$  causes the broader distributed local  $E_c$  and a larger  $FWHM$ . A stable  $FWHM$  over cycling signifies the maintenance of stationary  $V_O$  distribution.

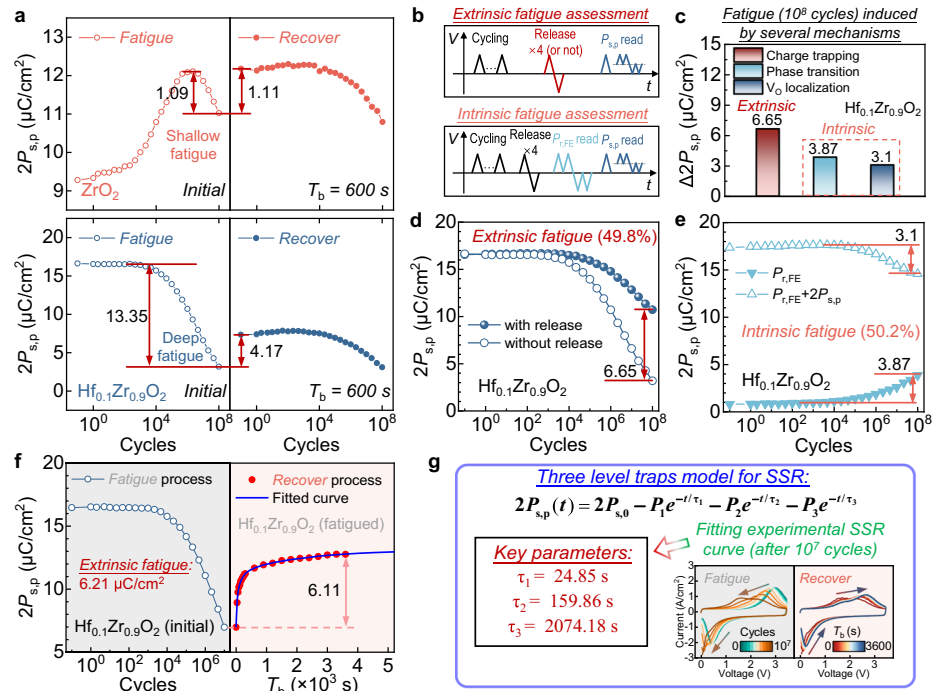
The comparison of  $2P_{s,p}$  and  $FWHM$  evolutions between the  $ZrO_2$  and  $Hf_{0.1}Zr_{0.9}O_2$  capacitors during Pos. cycling with 3.5 V at 200 kHz is exhibited in Fig. 2d. The  $ZrO_2$  capacitor shows wake-up effect with  $FWHM$  increasing until  $2 \times 10^6$  cycles, then fatigue occurs with the stable  $FWHM$ . While the  $Hf_{0.1}Zr_{0.9}O_2$  capacitor skips the wake-up process and begins fatigue after  $5 \times 10^3$  cycles with  $FWHM$  first increasing and then decreasing. Figure 2e shows the evolution of  $I-V$  curves with  $10^8$  cycles for the  $ZrO_2$  and  $Hf_{0.1}Zr_{0.9}O_2$  capacitors. Note that the changes in  $FWHM$ , including increase and decrease, indicate the redistribution of  $V_O$ <sup>16,17</sup>. During the cycling process, the stable  $FWHM$  with the shifted  $I-V$  curve means that charge trapping occurs in the capacitor, without the redistribution of  $V_O$ , which may be the leading fatigue mechanism in  $ZrO_2$  with  $10^8$  cycles. While the fatigue in  $Hf_{0.1}Zr_{0.9}O_2$  may be induced by the coupling of  $V_O$  charge trapping and redistribution. The experimental measured electron energy loss spectroscopy (EELS) maps shown in Supplementary Fig. 2 provides direct evidence for the  $V_O$  redistribution by extracting the evolution of oxygen (O) K-edge doublet ( $a/b$  ratio) and supports the explanation of the  $FWHM$  broadening observed in the electrical measurements. The different fatigue behaviors observed between  $ZrO_2$  and  $Hf_{0.1}Zr_{0.9}O_2$  are strongly influenced by the presence of Hf. In pure  $ZrO_2$ , where no Hf is introduced,  $V_O$  tend to be charged during electrical cycling, characterized by the shift of  $I-V$  curves with the limited change in the shapes of the curves. In contrast, in  $Hf_{0.1}Zr_{0.9}O_2$ , the introduction of Hf incorporation facilitates partial localization of  $V_O$  within the lattice and initiates AFE to FE PT, contributing to the significant change in the shapes of the  $I-V$  curves.

### Impact of fatigue mechanisms on the SSR characteristics

Endurance is a vital characteristic for memory devices. However, the endurance of AFE HZO devices reported so far is still insufficient to support DRAM-level applications. It has been extensively reported that recovery method is one of the most effective technologies to improve the endurance properties in FE and AFE materials. Figure 1c shows the schematic diagram of a typical recovery process. For  $HfO_2$ -based FE materials, higher electric field cycling is employed to recover the  $P_r$  fatigue caused by low electric field cycling, with its physical origin attributed to the redistribution of  $V_O$ <sup>16</sup>. The fatigue behaviors of  $HfO_2$ -based FE devices are fundamentally different with the ones of  $ZrO_2$ -based antiferroelectrics, where  $V_O$  charge trapping is not dominant. The  $ZrO_2$ -based AFE materials undergo a more complex phase transition process and fatigue mechanism, and the physical nature of its recovery has yet to be fully elucidated. In this article, guided by the exploration of the fatigue and recovery mechanisms, an SSR method is proposed for  $ZrO_2$ -based AFE capacitors. As shown in Supplementary Fig. 3b, the proposed SSR process can be briefly described as performing a certain period of break after cycling, realizing the self-recovery of polarization.

The comparison of SSR processes with 600 s break in  $ZrO_2$  and  $Hf_{0.1}Zr_{0.9}O_2$  capacitors is shown in Fig. 3a. The  $2P_{s,p}$  of  $ZrO_2$  capacitor decrease by  $1.09 \mu C/cm^2$  after  $10^8$  cycles and increase by  $1.11 \mu C/cm^2$  after 600 s break, which means complete recovery is realized within 600 s  $T_b$ . Here  $T_b$  is defined as the interval between the two continuous fatigue measurements for the same capacitor. Besides, Supplementary Fig. 4 and 5 show the evolutions of  $2P_{s,p}$  and the corresponding  $FWHM$  during SSR processes with 0/600/1200 s  $T_b$ . For  $T_b = 600$  s and 1200 s,  $2P_{s,p}$  is totally recovered during break, and the  $FWHM$  during 2<sup>th</sup> to 5<sup>th</sup> fatigue measurements keeps stable, indicating that there is no  $V_O$  redistribution during

**Fig. 3 | SSR characteristics and fatigue mechanisms analysis.** **a** Comparison of SSR processes with  $T_b$  of 600 s for  $ZrO_2$  and  $Hf_{0.1}Zr_{0.9}O_2$  capacitors. **b** Voltage waveforms used for extrinsic and intrinsic fatigue assessments. **c** Summary of the contributions from various mechanisms to deep fatigue after  $10^8$  cycles for  $Hf_{0.1}Zr_{0.9}O_2$ . **d** Endurance characteristics of the  $Hf_{0.1}Zr_{0.9}O_2$  capacitors, with and without charge release. **e** Evolution of  $P_{r,FE}$  and  $P_{r,FE} + 2P_{s,p}$  read by PUND and uni-PUND methods during  $10^8$  electrical cycling. **f** Fatigue and recover processes of  $Hf_{0.1}Zr_{0.9}O_2$  capacitors under  $10^7$  cycles, with  $T_b$  of 3600 s. **g** Proposed three level traps model in this work, with insets showing the evolutions of  $I-V$  curves during fatigue and SSR.



cycling. In this article, the totally recoverable fatigue in  $ZrO_2$ -based AFE capacitors under the SSR method is defined as shallow fatigue. In contrast, the  $2P_{s,p}$  of  $Hf_{0.1}Zr_{0.9}O_2$  capacitor exhibits a reduction of  $13.35 \mu C/cm^2$  after  $10^8$  cycles and increases by only  $4.17 \mu C/cm^2$  after 600 s break, corresponding to a recovery rate of 31.2%, and this partially recoverable fatigue in  $ZrO_2$ -based AFE capacitors under the SSR method is defined as deep fatigue.

It has been discussed in previous studies that there are three kinds of fatigue mechanisms in  $ZrO_2$ -based AFE capacitors, including  $V_O$  charge trapping, AFE to FE PT and  $V_O$  localization. The  $V_O$  charge trapping is classified as extrinsic fatigue, while the AFE to FE PT and  $V_O$  localization are classified as intrinsic fatigue<sup>27</sup>. As shown in Fig. 3a, the shallow fatigue in  $ZrO_2$  capacitor may mainly originate from  $V_O$  charge trapping, thus is totally self-recoverable after a certain  $T_b$ . While the deep fatigue in  $Hf_{0.1}Zr_{0.9}O_2$  may be caused by the coupling of all these fatigue mechanisms. By using the assessing methods proposed in ref 27., the contributions of these three mechanisms to deep fatigue after  $10^8$  cycles  $Hf_{0.1}Zr_{0.9}O_2$  capacitor are evaluated, and the voltage waveforms are shown in Fig. 3b. The fatigue values in  $2P_{s,p}$  caused by these mechanisms are summarized in Fig. 3c, in which the extrinsic one ( $V_O$  charge trapping) is  $6.65 \mu C/cm^2$ , accounting for 49.8% of the total  $2P_{s,p}$  fatigue, and the detailed  $2P_{s,p}$  versus cycles curves used to derive the assessed values are shown in Fig. 3d, e. It is evident that under  $10^8$  electrical cycles, the dominant fatigue mechanisms in  $ZrO_2$  and  $Hf_{0.1}Zr_{0.9}O_2$  capacitors diverge, leading to differences in their SSR behaviors. However, a comprehensive physical model capable of accurately describing and predicting the SSR characteristics of  $ZrO_2$ -based AFE capacitors remains elusive.

### Development of three level traps model

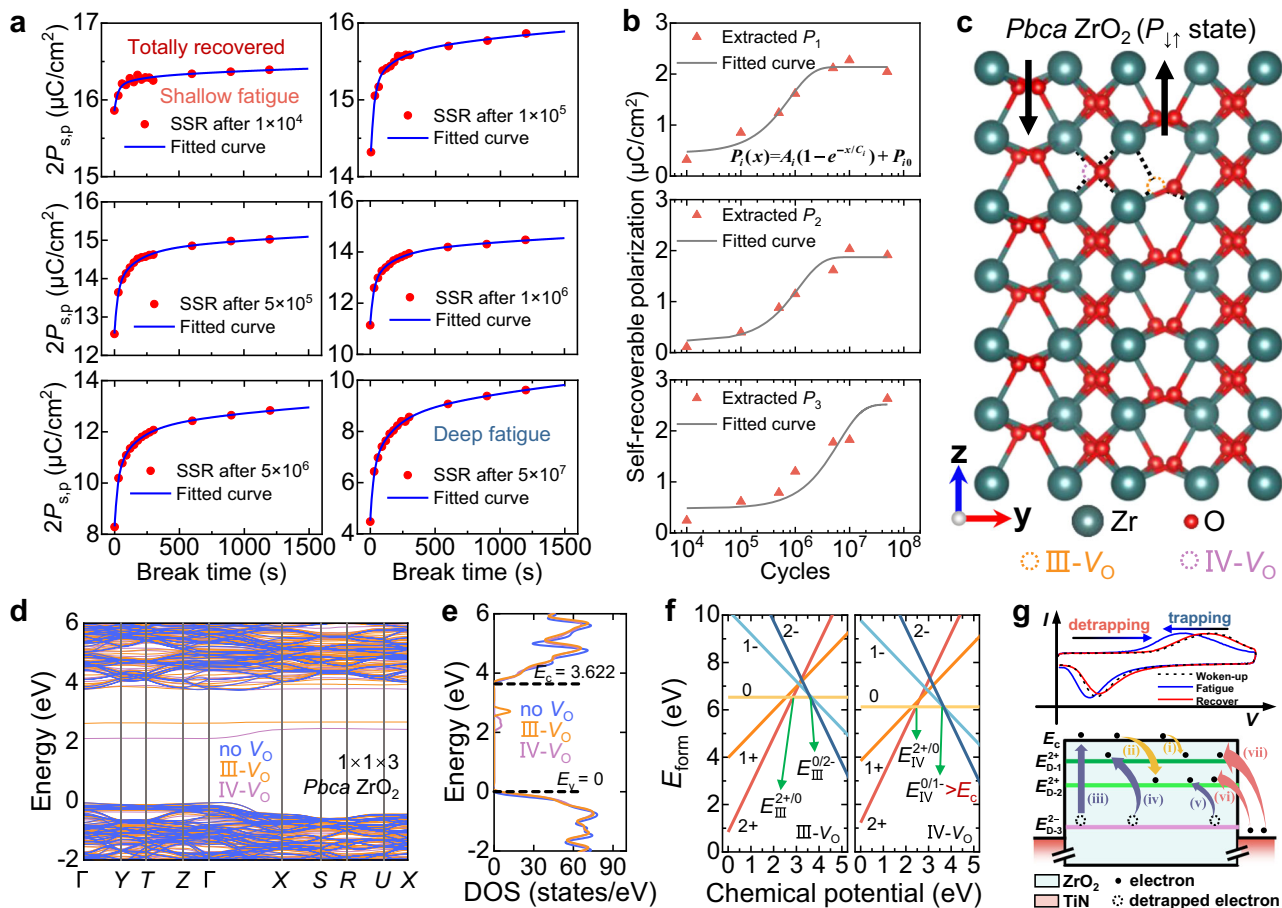
After figuring out the proportional contributions of different mechanisms in deep fatigue situation of  $Hf_{0.1}Zr_{0.9}O_2$ , further analysis of the SSR capability at varying  $T_b$  is conducted, as illustrated by the red scatter plot in the right panel of Fig. 3f. The maximum self-recoverable polarization through SSR can be approximately estimated at  $6.11 \mu C/cm^2$  (the difference between the recovered  $2P_{s,p}$  after SSR with a 3600 s break and the fatigued  $2P_{s,p}$  after  $10^7$  cycles), nearly equivalent to the magnitude of extrinsic fatigue extracted from Fig. 3d, which is  $6.21 \mu C/cm^2$  for  $10^7$  cycles. This indicates that SSR can

fully recover the extrinsic fatigue caused by charge trapping but has limited effectiveness in recovering intrinsic fatigue. Additional experiments on  $Hf_{0.1}Zr_{0.9}O_2$  capacitors have been conducted to extend the endurance measurements to  $10^9$  cycles, and the  $ZrO_2$  capacitors with inherently better endurance is expected to retain the  $2P_{s,p}$  of  $\sim 7 \mu C/cm^2$  even after  $10^{12}$  cycles via proper SSR strategy (Supplementary Fig. 6). As shown in Supplementary Fig. 7, it is revealed that the recoverable  $2P_{s,p}$  value ( $7.54 \mu C/cm^2$ ) shows excellent agreement with the measured extrinsic fatigue ( $7.22 \mu C/cm^2$ ), with a minor 4.4% difference. The alignment between these values at such high cycle counts provides compelling evidence that the break-time-dependent SSR process remains effective and that no significant new fatigue mechanisms emerge in this cycling regime. Notably, the totally self-recoverable shallow fatigue observed in  $ZrO_2$  capacitors may also stem from  $V_O$  charge trapping. Due to the strong correlation between the SSR process and charge detrapping, the multi-level defect detrapping model is referenced in this article<sup>29</sup>. The charge decay in dielectrics follows multi-exponential kinetics due to traps with distinct energy depths, where detrapping rates depend on temperature and defect energy levels. A three level traps model is proposed, which successfully reproduces the evolution of  $2P_{s,p}$  during SSR process in  $ZrO_2$  and  $Hf_{0.1}Zr_{0.9}O_2$  capacitors (Fig. 1d, e):

$$2P_{s,p}(t) = 2P_{s,0} - P_1 e^{-t/\tau_1} - P_2 e^{-t/\tau_2} - P_3 e^{-t/\tau_3} \quad (1)$$

where  $P_{s,0}$ ,  $P_i$  and  $\tau_i$  ( $i = 1, 2, 3$ ) represent for the saturated polarization value after sufficiently long SSR, the self-recoverable polarization and the effective lifespan for the corresponding trap energy level, respectively.

As shown in Fig. 4a, the experimental SSR curves for  $Hf_{0.1}Zr_{0.9}O_2$  after varying electrical cycles could also be fitted well. Besides, the shallow fatigue situation is also observed in  $Hf_{0.1}Zr_{0.9}O_2$  capacitors, depending on the precisely controlled number of electrical cycles, highlighting the intrinsic unity of the SSR behaviors in both  $ZrO_2$  and  $Hf_{0.1}Zr_{0.9}O_2$  capacitors and the universality of the three level traps model. The relationship of self-recoverable polarization ( $P_i$ ) and different electrical cycles could also be revealed, as illustrated by the orange scatter plot in Fig. 4b. These plots could



**Fig. 4 | Theoretical demonstrations for three level traps model.** **a** Experimental and fitted curves of the SSR processes in  $\text{Hf}_{0.1}\text{Zr}_{0.9}\text{O}_2$  capacitors after different fatigue cycles, using the fixed  $\tau$  parameters extracted from Fig. 3g. The specific fatigue cycles are  $1 \times 10^4$ ,  $1 \times 10^5$ ,  $5 \times 10^5$ ,  $1 \times 10^6$ ,  $5 \times 10^6$  and  $5 \times 10^7$ , respectively. **b** Extracted values of  $P_1$ ,  $P_2$  and  $P_3$  as a function of electrical cycles and their respective fitting curves. **c** Schematic diagram of  $1 \times 1 \times 3$   $\text{PbcZrO}_2$  supercell,

highlighting the locations of neutral III-V<sub>O</sub> and IV-V<sub>O</sub>, marked by orange and purple dashed circles, respectively. **d, e** First-principles calculated  $E-k$  dispersion and DOS spectra for supercells with various O-deficient configurations. **f** Plot of the formation energy of different charged V<sub>O</sub> as a function of the chemical potential. **g** Schematic illustration of mechanism for SSR and possible detrapping routes for  $E_{D-1}^{2+}$ : (i), (iv), (vii);  $E_{D-2}^{2+}$ : (ii), (v), (vi);  $E_{D-3}^{2+}$ : (iii), (iv), (v).

be described as (gray curves in Fig. 4b):

$$P_i(x) = A_i(1 - e^{-x/C_i}) + P_{i0} \quad (2)$$

where  $C_i$  is the numbers of electrical cycles that saturate  $P_i$ ,  $P_{i0}$  is the initial trapped charge.

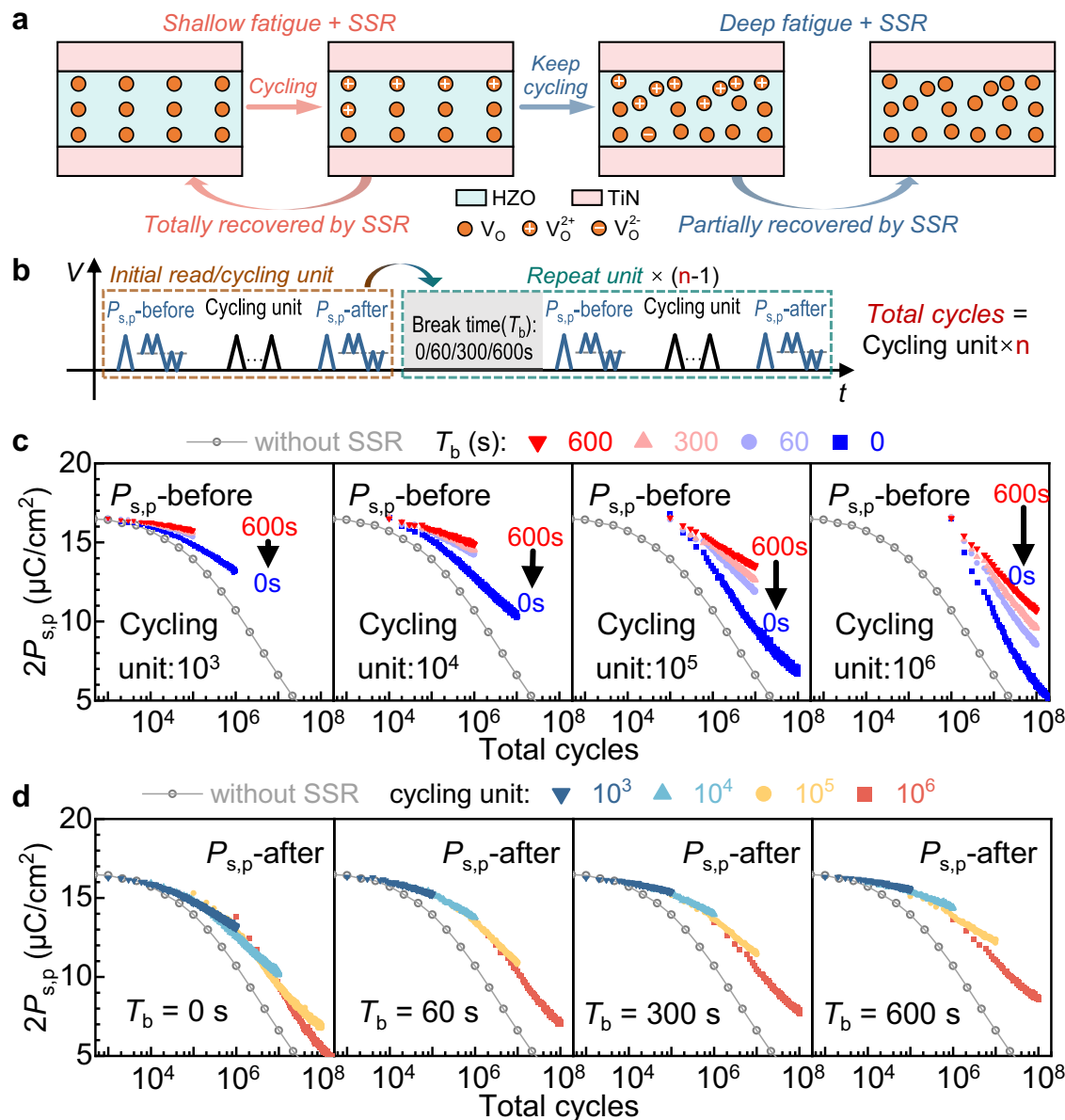
Furthermore, the three level traps model can be supported by density functional theory (DFT) calculations. Here,  $1 \times 1 \times 3$   $\text{PbcZrO}_2$  supercells are constructed to theoretically calculate the trap energy level distributions, as shown in Fig. 4c. The O-deficient configurations are constructed by removing one O atom from the supercells, with the orange and purple dashed circles marking the localizations of neutral III-V<sub>O</sub> and IV-V<sub>O</sub>, respectively. Considering the primary aim of evaluating the electronic structure of AFE ZrO<sub>2</sub> in its antipolar ground state, the two selected V<sub>O</sub> positions (one III-O site and one IV-O site) are sufficient to capture the representative variation in local environments and corresponding defect level distributions, owing to the presence of inversion symmetry. Then, the bulk electronic band structure calculations of supercells with different O-deficient configurations were performed. Figure 4d, e plot the calculated energy-momentum ( $E-k$ ) dispersion and density of states (DOS) of ZrO<sub>2</sub> supercells with neutral III-V<sub>O</sub>, IV-V<sub>O</sub> and without V<sub>O</sub>. The band gap between valance band maximum and conduction band minimum is around 3.622 eV, and the localizations of defect energy levels for neutral III-V<sub>O</sub> and IV-V<sub>O</sub> are confirmed. The formation energies for V<sub>O</sub> could be theoretically

estimated by:

$$E_q^{form}(\mu_e) = E_q^{N-1} + \frac{1}{2}E(\text{O}_2) + q\mu_e - E^N \quad (3)$$

where  $E_q^{N-1}$  is the total energy of the supercell with different charged V<sub>O</sub>,  $N$  is the number of total atoms,  $q$  is the charge number,  $E(\text{O}_2)$  is the energy of an isolated oxygen molecule,  $\mu_e$  is the chemical potential, and  $E^N$  is the total energy of the supercell without V<sub>O</sub>.

The calculated formation energies of the different charged V<sub>O</sub> as a function of  $\mu_e$  are illustrated in Fig. 4f, and three transition levels are confirmed as  $E_{III}^{2+/0}$ ,  $E_{III}^{0/2-}$  and  $E_{IV}^{2+/0}$ , indicating V<sub>O</sub> are more likely to be charged at three trap energy levels during cycling, which are named as  $E_{D-1}^{2+}$ ,  $E_{D-2}^{2+}$  and  $E_{D-3}^{2+}$ . Assuming that these three trap energy levels are all above the middle of band gap, and their relative positions are schematically illustrated in Fig. 4g. Possible V<sub>O</sub> detrapping routes for  $E_{D-1}^{2+}$  are: (i) electrons transition from conduction band ( $E_C$ ), (iv) electrons transition from  $E_{D-3}^{2+}$  to  $E_{D-1}^{2+}$ , (vii) tunneling electrons from electrodes; for  $E_{D-2}^{2+}$  are: (ii) electrons transition from  $E_C$ , (v) electrons transition from  $E_{D-3}^{2+}$  to  $E_{D-2}^{2+}$ , (vi) tunneling electrons from electrodes; for  $E_{D-3}^{2+}$  are: (iii) electrons transition from  $E_{D-3}^{2+}$  to  $E_C$ , (iv) electrons transition from  $E_{D-3}^{2+}$  to  $E_{D-1}^{2+}$ , (v) electrons transition from  $E_{D-3}^{2+}$  to  $E_{D-2}^{2+}$ . The energy level differences associated with electron detrapping from V<sub>O</sub> during the self-recovery of extrinsic fatigue are



**Fig. 5 | Application of SSR in  $\text{Hf}_{0.1}\text{Zr}_{0.9}\text{O}_2$  capacitors during continuous cycling processes.** **a** Schematic diagrams of  $V_O$  evolutions during shallow/deep fatigue and corresponding SSR processes. **b** Voltage waveform for continuous cycling unit and

the timing of  $P_{s,p}$ -before and  $P_{s,p}$ -after read. **c** Comparison of  $P_{s,p}$ -before and **d**  $P_{s,p}$ -after under different  $T_b$  and cycling unit. Both of increasing  $T_b$  and decreasing cycling unit can improve endurance.

indeed thermally surmountable through two key mechanisms: (1) The effective detrapping rate from deep traps ( $\sim 1.0$ - $1.2$  eV) follows a Boltzmann distribution where a small but non-zero fraction of carriers ( $\exp(-E_a/k_B T)$ ) can overcome the barrier at room temperature, especially given the high attempt frequency ( $\sim 10^{12} \text{ s}^{-1}$ ) in oxide materials, (2) the observed recovery of deep fatigue occurs over macroscopic timescales ( $10^2$ - $10^3$  s), allowing sufficient time for statistically rare thermal excitation events to accumulate. This is evidenced by our three-level trap model's excellent fit to the recovery kinetics (with  $\tau_1 \sim 24.85$  s,  $\tau_2 \sim 159.86$  s,  $\tau_3 \sim 2074.18$  s) inherently accounts for thermally activated detrapping processes.

**Optimization of cycling unit and  $T_b$  combination**

It has been proved above that the shallow fatigue can be totally recovered by SSR, and for deep fatigue, the extrinsic  $P_r$  degradation caused by charge trapping can also be totally recovered by SSR, while the intrinsic one cannot. Figure 5a presents the schematic diagrams illustrating  $V_O$  evolutions during both shallow and deep fatigue conditions, as well as the corresponding SSR

processes. These visualizations clearly elucidate the mechanisms that lead to both totally and partially recovered polarization degradation.

It is worth considering how to effectively apply SSR to further improve the endurance of devices. Therefore, the abilities of SSR with various combinations of different cycling unit and  $T_b$  in  $\text{Hf}_{0.1}\text{Zr}_{0.9}\text{O}_2$  capacitors are investigated, in which the cycling unit is defined as several continuous electrical cycles. Figure 5b shows the measurement scheme, in which the repeat unit is defined as the combination of  $T_b$ , read before cycling ( $P_{s,p}$ -before), cycling unit and read after cycling ( $P_{s,p}$ -after). Different degrees of endurance improvement are realized by applying various combinations of cycling unit ( $10^3/10^4/10^5/10^6$  cycles) and  $T_b$  (0/60/300/600 s), and the fatigue without SSR is also plotted as a reference. Figure 5c, d show the comparison of  $P_{s,p}$ -before and  $P_{s,p}$ -after under different  $T_b$  and cycling unit. For fixed cycling unit, the SSR effect is greatly enhanced with increasing  $T_b$ , shown in Fig. 5c. This means that during the cycling, the more charges trapped in the  $\text{ZrO}_2$ -based AFE devices are released by SSR, thus preventing deep fatigue, the more effective endurance can be enhanced. And for fixed  $T_b$ , the

endurance can be improved with decreasing cycling unit, shown in Fig. 5d. This means that during a single cycling unit, a lower accumulation of trapped charges may enhance the efficacy of SSR in enhancing endurance. Notably, while employing Keysight B1530A Waveform Generator to perform these electrical measurements, a brief delay is inherently introduced by the measurement system itself. Specifically, during the automatic switching between the cycling and readout modules within the test sequence, a finite recovery time approximately 0.8 seconds is inevitably incurred. This delay, although not user-defined, can provide partial recovery for the device, thereby contributing to the observed endurance improvement even under nominal  $T_b = 0$  s conditions. Finally, it has been demonstrated that avoiding deep charge trapping by SSR is effective for the endurance improvement of the ZrO<sub>2</sub>-based AFE devices. To further support this approach, a self-sensing circuit has been proposed (Supplementary Fig. 8), which could potentially enable SSR application in future implementations.

## Conclusions

In summary, through an in-depth investigation of the fatigue behavior in AFE ZrO<sub>2</sub> and Hf<sub>0.1</sub>Zr<sub>0.9</sub>O<sub>2</sub> capacitors, we successfully decouple the contribution of V<sub>O</sub> charge trapping and uncover the underlying SSR phenomenon. A three level traps model is proposed, which can reproduce and predict the evolution of  $2P_{sp}$  during SSR process. The proposed mechanisms for SSR are confirmed by DFT calculations and summarized in Fig. 4. Then, the ability of SSR for deep fatigue was investigated. The introducing of SSR in the break of two cycling processes could effectively relieve fatigue. By optimizing the combination of  $T_b$  and cycling unit to avoid deep fatigue (decrease the concentration of deep trapped charged V<sub>O</sub>), the endurance performance would be greatly improved. The utilization of SSR shows promise in addressing the endurance issues of AFeRAM in practical applications.

## Methods

### Device fabrication

The fabrication of ZrO<sub>2</sub>/Hf<sub>0.1</sub>Zr<sub>0.9</sub>O<sub>2</sub> AFE capacitors starts from silicon (Si) substrate. After conventional RCA wet clean, a 50 nm-thick TiN layer is deposited as bottom electrode (BE) on Si substrate by reactive sputtering. Then, the samples are loaded into the atomic layer deposition (ALD) chamber for 10 min O<sub>3</sub> treatment on TiN BE<sup>23</sup>. Next, 10 nm ZrO<sub>2</sub>/Hf<sub>0.1</sub>Zr<sub>0.9</sub>O<sub>2</sub> AFE film is in situ deposited via ALD using tetrakis-dimethylamino hafnium (TDMAHf) and tetrakis-dimethylamino zirconium (TDMAZr) as precursors, and H<sub>2</sub>O as oxidant at 250 °C. The growth rates of HfO<sub>2</sub> and ZrO<sub>2</sub> are 0.71 and 0.67 Å/cycle, respectively. During the deposition of Hf<sub>0.1</sub>Zr<sub>0.9</sub>O<sub>2</sub> AFE film, HfO<sub>2</sub> cycles are uniformly inserted in ZrO<sub>2</sub> cycles, and one HfO<sub>2</sub> cycle followed by nine ZrO<sub>2</sub> cycles as a supercycle is employed. Subsequently, 50 nm-thick TiN is deposited by reactive sputtering and patterned for top electrode (TE). The size of characterized devices is 11304 μm<sup>2</sup>. Finally, post-metallization annealing (PMA) at 500 °C for 30 s in N<sub>2</sub> atmosphere is performed to crystallize ZrO<sub>2</sub>/Hf<sub>0.1</sub>Zr<sub>0.9</sub>O<sub>2</sub> films.

### Characterizations

Cross-sectional transmission electron microscope (TEM) measurements were performed on a ThermoFisher Talos F200X to confirm the metal-AFE-metal structure of fabricated AFE HZO capacitors and the thickness for HZO film. GIXRD measurements were carried out on a Bruker D8 Discover (Cu-Kα radiation, λ = 0.154 nm) for structural analysis of the capacitors. Electrical measurements were carried out on aixACCT TF Analyzer 3000 and Keysight B1500A semiconductor device analyzer.

### First-principles calculations

Band structures were calculated in the framework of DFT using the QUANTUM ESPRESSO v6.8 package. Ultrasoft pseudopotentials with generalized gradient approximation (GGA) and Perdew-Burke-Ernzerhof (PBE) exchange correlation were used<sup>30–32</sup>. The 1 × 1 × 3 supercells with different O-deficient configurations were constructed based on the ZrO<sub>2</sub>

primitive cell with *Pbca* space group (a = 5.126 Å, b = 10.037 Å, and c = 5.102 Å). According to the convergence tests, the kinetic energy cutoff for the electron wavefunctions is set as 816 eV, and an 8 × 4 × 3 Monkhorst-Pack k-point sampling is used for the Brillouin zone integration in the structure relaxation.

## Data availability

The source data of all the plots of main manuscript and Supplementary Information are available as Supplementary Data.

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## Author contributions

H.Q., C.J. and J.C. proposed and implemented the project. R.S., J.X., M.Z., M.M., Y.D. X.L. G.L. J.G. and R.C. fabricated the devices and performed the experimental verification of the device structures. H.Q. conducted electrical measurements and first-principles calculations. Y.L., Y.H. and G.H. helped with data analysis. All authors contributed to write up of the manuscript. G.H. organized and supervised the whole project implementation and provided the project financial support.

## Competing interests

The authors declare no competing interests.

## Additional information

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